



AP  
JFW

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:  
David Wei Wang

Serial No.: 10/626,916

Filed: July 25, 2003

For: Mesh Screen Apparatus and Method of  
Manufacture

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Group Art Unit: 3672

Examiner: House, Letoria G.

Atty. Docket: 68.0345

Commissioner  
for Patents  
PO Box 1450  
Alexandria, VA 22313-1450

CERTIFICATE OF MAILING  
37 C.F.R. 1.8

I hereby certify that this correspondence is being deposited with the U.S. Postal Service as First Class Mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on the date below:

May 5, 2006

Date

Robert A. Van Someren

**REPLY**

Dear Sir:

In response to the Office Action mailed March 16, 2006, Applicants submit the  
following: